

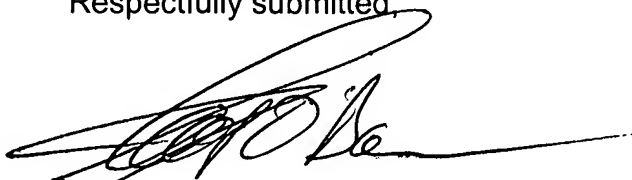
REMARKS

This First Preliminary Amendment is respectfully submitted to present device claims rather than method claims as set forth in the parent case. Entry is respectfully requested. In addition, the Applicant has also amended the specification on page 6 to use consistent terminology.

The Applicant also respectfully requests a telephone interview with the Examiner at the time the Examiner is prepared to render a first action on the merits.

Date: 5/21/02

Respectfully submitted,



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VERSION OF AMENDMENTS WITH MARKINGS TO SHOW CHANGES

IN THE SPECIFICATION:

The paragraph beginning on page 6, line 4 has been amended as follows:

Another object of the invention is to ion cut a material in a region spaced apart from the location where atoms are [injected] introduced into the material.